

**Notice of References Cited**

Application/Control No.

10/619,626

Applicant(s)/Patent Under  
Reexamination  
TAKEUCHI ET AL.

Examiner

Omar F. Fernández Rivas

Art Unit

2129

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,055,491	04-2000	Biliris et al.	702/176
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Li et al. "GPS Time Series Modeling by Autoregressive Moving Average Method: Application to the Crustal Deformation in Central Japan", 2000, pages 155-162.
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	W	
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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